Point Autofocus Probe

(ISO 25178-605)

# POINT AUTOFOCUS PROBE SURFACE TEXTURE MEASURING INSTRUMENT **PF-60**

Faster Easier More precise



Mitaka

11

# Measure large areas quickly

### Large measuring area / high precision measurement

The laser probe with a radius of 0.5 $\mu$ m and the precision XY stage directly measure an area of several tens of millimeters down to the sub-micrometer level (measuring range: XYZ=60mm X 60mm X 10mm, scale resolution: XY=0.1 $\mu$ m, Z=0.01 $\mu$ m)



#### Fast 3D measurement

#### **1hour 20 minutes** (conventional instruments) > 6 minutes per 128000 points

Fast scanning autofocus (AF) function provides large measuring area and high precision measurement



# Higher precision / easier operation

## Excellent angle tracking capability

The highly sensitive autofocus sensor captures low levels of light reflected from the surface of the sample and directly measures steep angles and step heights.



# Maximum measurable angle : 87 degrees



## Measure visually!

# High precision measurement with easy operations

The objective changer (with a slide mechanism) switches between a low power objective for observation and a high power objective for measurement in a single step operation





Monitor the sample while measuring



5X objective eld of view (3.2×2.4mm) sample microencoder measuring point

Positioning of the

100X objective eld of view (0.16×0.12mm) measuring spt alignment mark



measuring pitch X = 1 m, Y = 1 m

## **ISO approved Mitaka measuring method**

We proposed our measuring principle to the International Standards Organization (ISO) as a non-contact measuring method. Our principle has been included in ISO 25178-6:2010 - Classi cation of methods for areal surface texture - under the name "Point Autofocus Pro ling" (ISO 25178-605: Point autofocus probe).





## Measuring principle

#### **Overview**

The PF-60 consists of an autofocus laser beam microscope (AF microscope) and a high precision XY scanning stage. The AF microscope measures height in the Z axis and the XY stage moves the sample in order to obtain XYZ coordinate values for 2D and 3D measurements.

#### Scanning XY stage

The PF-60 drives the high-precision XY stage to obtain the coordinate values in its full range of movement (60mm x 60mm). There is no need to stitch measured data since the PF-60 has no measuring limits (such as a restricted field of view) and hence provides high precision measurement of a large area.

#### High correlation with the international standards for roughness measurement

Point autofocus profiling (PAP) has a high correlation with roughness standard materials for stylus instruments and obtains reliable data.

Roughness standardTypeD1 (ISO5436-1) Tip radius 5 m Calibration PTB (Germany) Measurement methodstylus Measured length (In)4mm
 Cuto value( c): 0.8mm (Stylus tip radius R=5 m) PTB Roughness parameters PTB inspection result Ra 0.227 m(±3%) Rz 1.50 m(±4%) Measured data PF-60 Roughness parameters Ra 0.228 m Rz 1.56 m

(PAP laser spot radius R=0.5 m)

#### Point autofocus probe

The laser beam incorporated in the AF microscope passes through the objective (indicated by the red line in the above diagram) and forms a laser spot on the surface of the sample as a "probe" with a radius of 0.5µm.

The reflected laser beam from the sample surface passes through the objective again and forms an image on the autofocus sensor (AF sensor). The AF sensor detects the laser spot displacement in real time and adjusts the AF microscope back to the in-focus position (the laser spot forms its image at the center of the AF sensor).

#### Autofocus optical sytem cuts ghost and stray light

The autofocus optical system cuts out unnecessary light to achieve targetted measurement.



Transmissive surface



Secondary re ection of a Vee-groove

## **Surface texture measuring functions**

#### 2D roughness & contour

#### Surface topography & areal roughness

Ra = 0.104 Sm = 10(m) Roughness standardRubert) Measured dataRa=0.101, Sm=10(m) Scanning speed300 m/S



Measuring result for the contour standard





## Various auxiliary functions

#### Image capture

The image capture function displays the scale and saves images within the measuring software environment. It facilitates positioning over the measuring area, makes it possible to observe the sample surface during measurement, and provides size measurement within the field of view.



#### Mask measurement

Mask measurement provides three types of 3D measurement: inner circle measurement, outer circle measurement and doughnut measurement.

This function reduces total measuring and assessment time by selecting a restricted measuring area.



#### Temperature correction software

This software ensures that, even when the PF-60 is installed in a non-temperature-controlled room, it maintains measuring accuracy at the sub-micrometer level.



#### Patching

Patching increases vertical range virtually by combining sets of 3D data that are measured at different heights with respect to the same XY stage coordinate system.



# Surface Texture Measurement comes in 3D

Microlens arrays (optical component)



Precision molding die



Wear volume of a brake pad (tribology)



Tooth ank roughness of a precision gear (precision processing)



Surface defect of a LED lens (optical component)



Tip of a turning tool



HDD head suspension (precision blanking)



Grinding work surface (precision processing)



# Perfect solution for measuring all kinds of surface topography

High-density mounting board (electronic component)



Microencoder (MEMS)



Flow marks ( ow lines) of a molding



Fingerprint (medical & cosmetics)



BGA(semiconductor)





Braille (welfare)



Human hair (cosmetics)



# 3D Surface Texture Analysis Software MitakaMap ST

Interactive and user-friendly software complete with powerful online help. Advanced analysis is carried out by applying straightforward operations to measurement data.





1.2 m

-150 -200 J.B.

-300

-350

-400

0.15482 n -250

23

ш

015459

04 03

24

0.5

æ

015467

0 0.8 0.9

25.4

шш

24

# MitakaMap ST Automatic Analysis Tools

Surface metrology reports include comprehensive analysis results

### Inspection report creation

Reports containing analytical studies are created frame by frame in an intuitive desktop publishing environment. Headers, company logos, etc. on a master page are repeated on all pages of a report.



#### Batch processing of data

Prepare an inspection report on a single data set and use it as a template for analyzing all similar data sets.

8

Creating automatic inspection reports

#### Supporting 10 languages

MitakaMap supports 10 languages, facilitating global cooperation.

[Supported la	nguage		
Japanese	English	French	Germa
Italian	Chinese	Korean	Spani
Polish	Brazilian I	Portuguese	

an sh

# MitakaMap XT Expert

MitakaMap XT is available as an upgrade to MitakaMap ST (standard software) and contains parameters required for R&D and specialized applications. It also provides extended quantitative analysis of surface texture.



\*also available in ST

OPTION

# **Advanced Contour Module**

Additional operators and studies for Contour Analysis (standard) and Advanced Contour Analysis (optional module) provide powerful dimensional and form deviation analysis



#### Batch processing of data

Tabulating the analysis results and automatically displaying deviations from pre-defined tolerances

Parameter	Value	Lower limit	Upper limit	Pass or Fail
Radius [2]	1500.99 um	1498 um	1502 um	Pass
Radius [3]	199.25 um	105 um	205 um	Pass
Radius [4]	2005 um	195 um	205 um	Page
Radius [5]	198.90 um	195 um	205 um	Pass
Radius (6)	194.17 um	195 um	205 um	Fail
Radius [7]	201 52 um	195 um	206 um	Pasa
Radius (8)	198.47 um	195 um	205 um	Pass
Radius [9]	197.07 um	195 um	205 um	Page
Distance [12]	1500.24 um	1499 um	150t um	Pass
Distance [14]	10000.49 um	9969 um	10001 um	Page

#### CAD data comparison

Loading CAD data in order to compare measured profiles with design specifications



Analyzing contact points and center coordinates with respect to virtual circles

Dimensional analysis of osculating circle



# Motifs Analysis

Dividing surface asperity into ridge and course lines in order to extract local peaks and pits for detailed surface observations



Specification



Mechanical Section					Software	
Axes	X axis	Y axis	AF (Z1) axis (for measurement)	Z2 axis (for positioning)	<ul> <li>○ 2D/3D surface texture measuring software</li> <li>■ Profile</li> </ul>	
Measuring range	60mm	60mm	10mm	60mm	Areal	
Positioning resolution	0.1 µm	0.1 µm	0.01 μm	0.1 μm	<ul> <li>(index/ scanning mode)</li> <li>3D surface texture analysis software (MitakaMap ST)</li> <li>■ Profile surface analysis texture analysis (ISO 4287) roughness / waviness / primary profile</li> </ul>	
Scale	Glass Scale	Glass Scale	Glass Scale	Pulse		
Accuracy (L=length in mm)	(2+4L/1000)μm	(2+4L/1000) μm	(0.3+0.5L/10) μm			
	Repeatability	$\sigma$ =0.03 µm (at mirror (specimen) surface)			Areal surface texture analysis (ISO 25178)	
Autofocus optical system	Focus area	$\phi$ 1 µm (with 100X objective)			Areal height parameters	
	Laser	Semiconductor laser (o/p: 1mW Max $\lambda$ : 635nm class 2)			Image: Straight of the straig	
	Objective for measurement	100X (WD=3.4mm NA=0.8) obervation mag : approx.1100X (9-in monitor)			<ul> <li>Morphological filters</li> <li>Abbott Curve</li> <li>Distance, Step-height analysis</li> <li>Volume of holes and peaks</li> </ul>	
	Objective for positioning	5X (slide mechanism) [field of view]				
	Epi-illumination	Köhler illumination (light source: white LED )			<ul> <li>Minidocs</li> <li>Illustrations</li> <li>10 languages supported</li> </ul>	
	Dimensions of XY stage 210×210mm		O Image Capture (Mitaka Veiwer)			
Other	Max sample size	70mm (up to 100mm in height with AF unit)			Teticle/scale display      saving images     Data export     Excel-compatible ASCII text files	
	Max sample weight	4kg				
	Instrument size (WxDxH)	Mechanical section: 400 × 400 × 450mm			Optional software	
	Vibration isolator	3 point supporting pad (proper oscillation lateral: 3.5 vertical: 4Hz)			O Advanced Contour Module	
	Instrument weight	31kg		OMotifs Analysis OStatistics		
Controller		○Upgrade to MitakaMap XT				
User interface Personal computer (OS: Windows)			Other options			
Drive control		4-axial controller (MSCN-4N)		○50X objective (WD=10.6mm NA=0.5) ○High NA100 X objective (WD=0.35mm NA=0.95)		
Power consumption (total)		250W (100V2.5A)				

#### **Product Portfolio**

#### Introduction

Mitaka Kohki provides a range of point autofocus probe measuring instruments including NH-Series, non-contact 3D measuring instruments, and MLP-2, a 360 degree form measuring instrument. The NH-Series is a perfect solution for measuring dimensions and surface texture and the MLP-2 is ideal for rotative measurement. Mitaka point autofocus systems are widely installed in ultraprecision machining manufacturers, electronic components, optical components and other industrial fields.



Model: PF-150 (6-inch scanning model) Measuring range: XYZ = 150mm X 150mm X 10mm Scale resolution: XYZ =  $0.1\mu$ m,  $0.1\mu$ m,  $0.01\mu$ m Applications: grinding wheels, optical components, molds and dies, etc. Model: PF-600 (large scanning model) Measuring range: XYZ = 600mm X 600mm X 10mm Scale resolution: XYZ = 0.1µm, 0.1µm, 0.01µm Applications: large optical components, large molds and dies, LCD panels, etc.

Mitaka



Model: NH-3SP (Super precision model) Measuring range: XYZ = 150mm X 150mm X 10mm Scale resolution: XYZ = 0.01µm, 0.01µm, 0.001µm Applications: aspherical lenses, semiconductors, precision molds, etc.



Model: MLP-2 (360-degree measurement model) Measuring range: XYZ = 120mm X 90mm X 130mm AF (R) = 40mm, AZ ( $\theta$ ) = 360° Scale resolution: XYZ = 0.1µm, 0.1µm AF (R) = 0.01µm, AZ ( $\theta$ ) = 0.001° Applications: precision gears, endmills, punches, molds for connectors, etc.



Distributor



For information only. Speci cations subject to change without prior notice.



1-18-8 Nozaki, Mitakashi, Tokyo 181-0014 Japan TEL +81(0)422-49-1491 FAX +81(0)422-49-1117 http://www.mitakakohki.co.jp E-mail: sales@mitakakohki.co.jp